

Neutron Reflectivity Investigation of the Propagation of Melt Polymers across a Glassy Interface

CHRNS School on Methods and Applications of SANS and NR

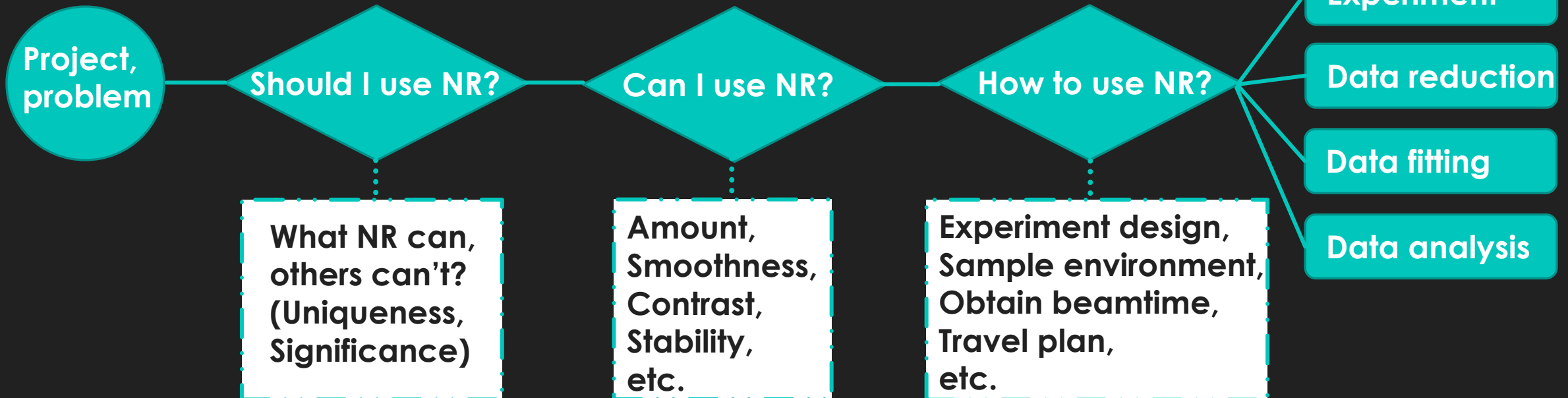
NIST Center for Neutron Research

July 2024

Schedule & Content

General Introduction (~ 2.5 hr)

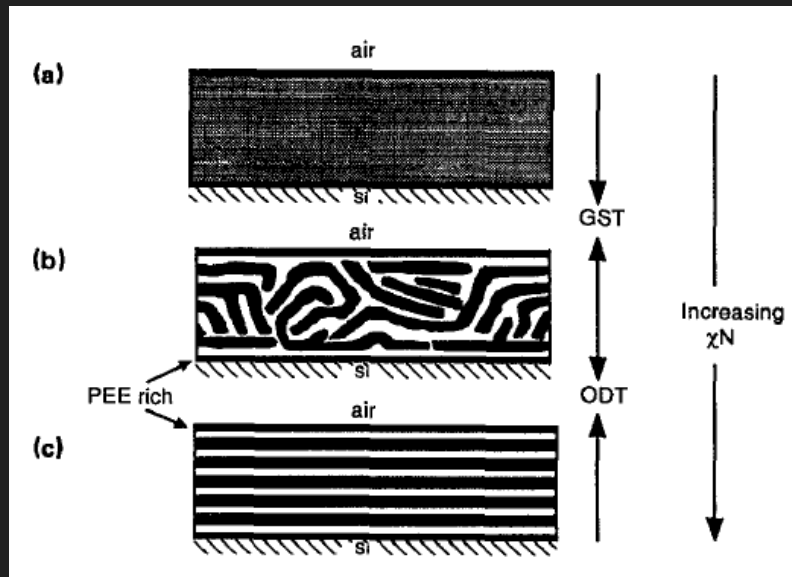
Case study (~ 3.5 hr)



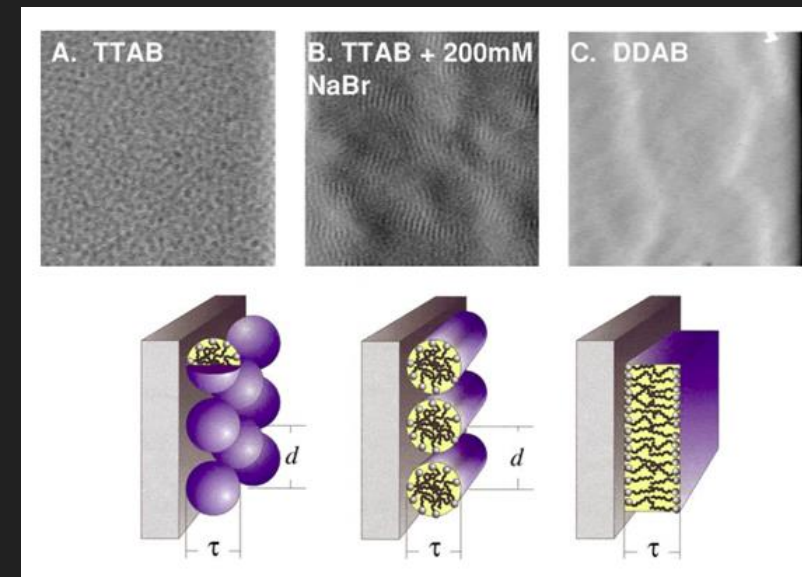
What NR is for?

Neutron reflectometry is a technique for investigating the thickness and the chemical composition of one or several **thin layers** at a **surface** or an **interface** of **many materials**.

○ Application examples (air-solid interface)



J. Chem. Phys., Vol. 96, No. 11, 1992

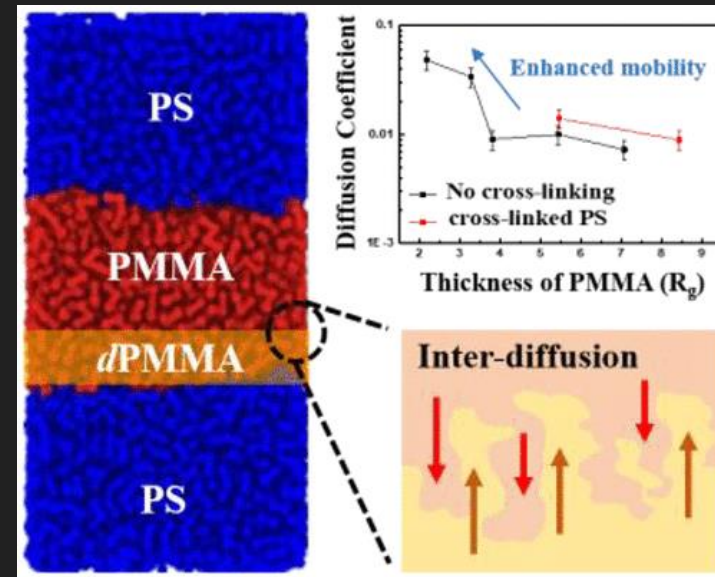
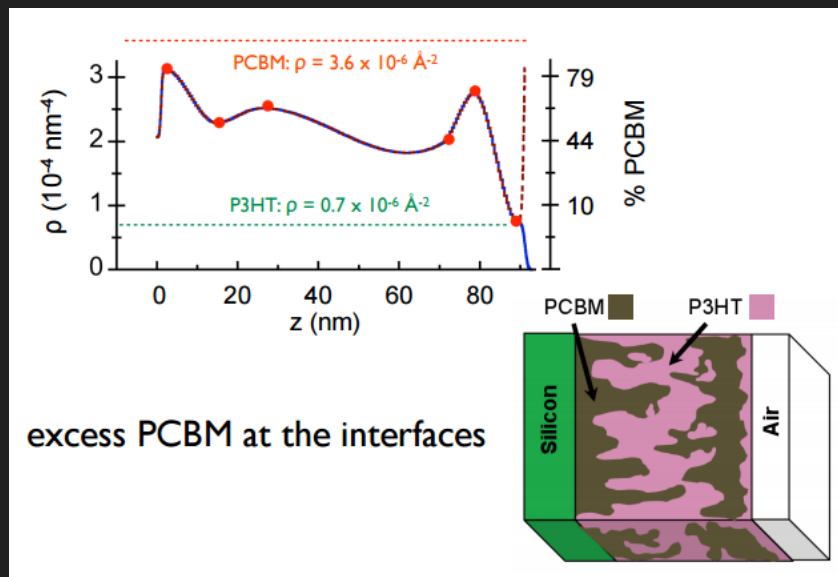


PHYSICAL REVIEW E, VOL 63, 041604

What NR is for?

Neutron reflectometry is a technique for investigating the thickness and the chemical composition of one or several **thin layers** at a **surface** or an **interface** of **many materials**.

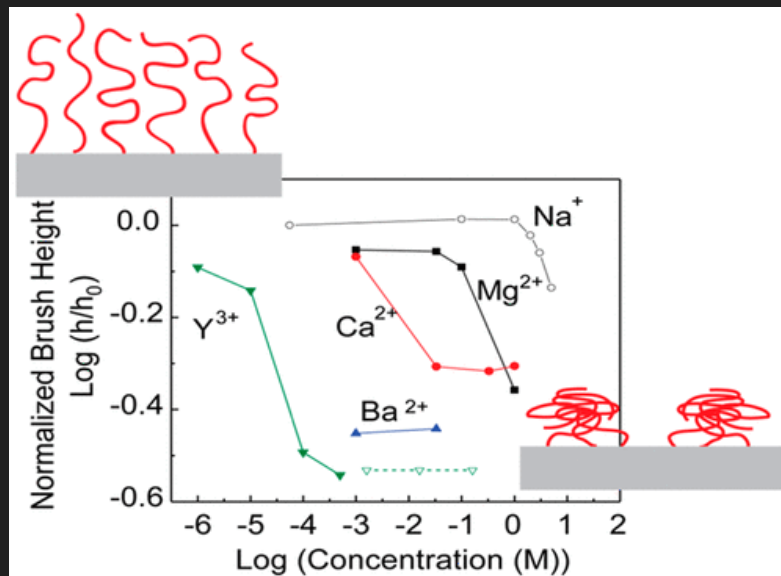
○ Application examples (solid-solid interface)



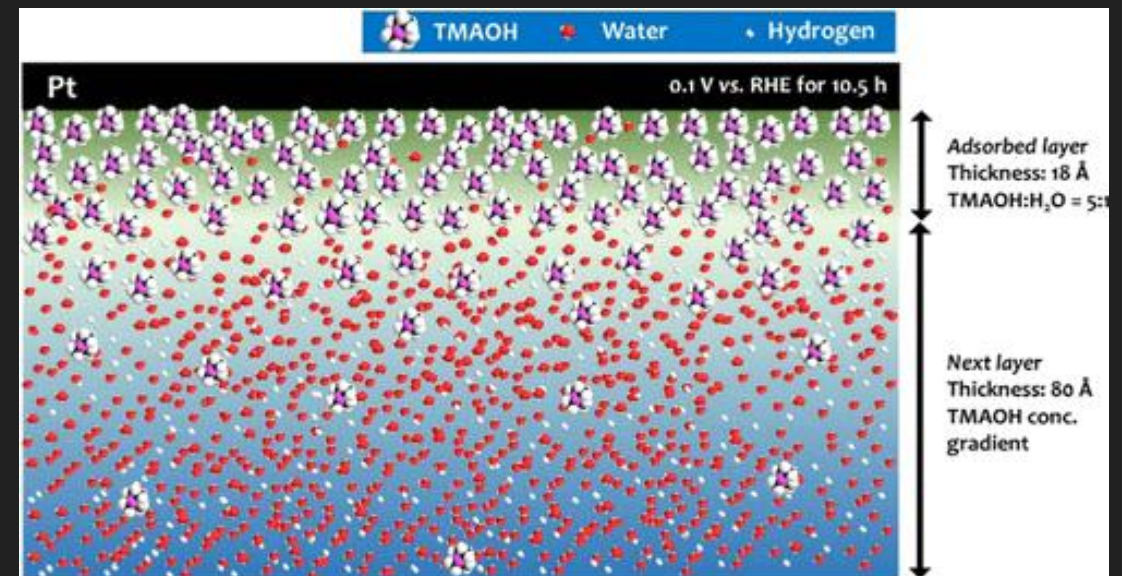
What NR is for?

Neutron reflectometry is a technique for investigating the thickness and the chemical composition of one or several **thin layers** at a **surface** or an **interface** of **many materials**.

○ Application examples (liquid-solid interface)



Macromolecules 2016, 49, 15, 5609–5617

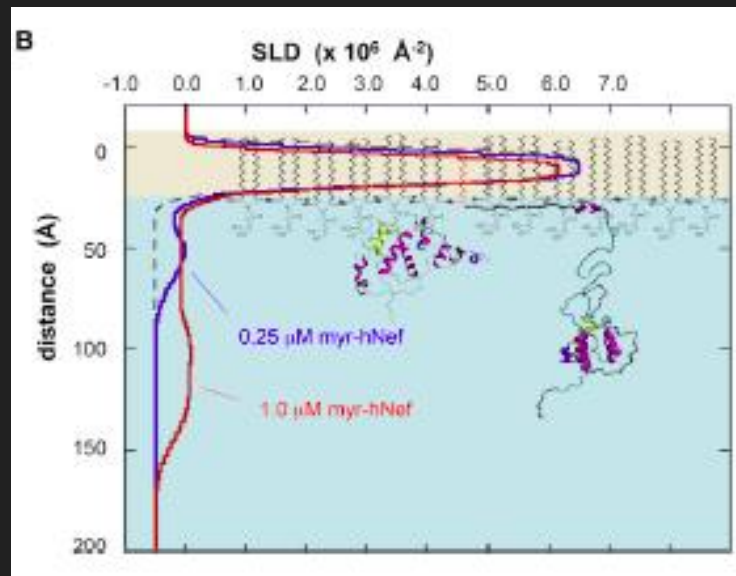


ACS Appl. Mater. Interfaces 2020, 12, 1825–1831

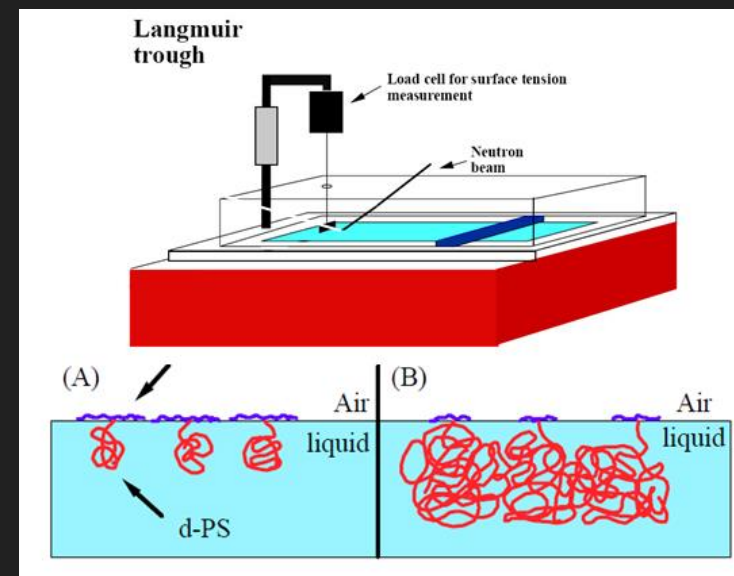
What NR is for?

Neutron reflectometry is a technique for investigating the thickness and the chemical composition of one or several **thin layers** at a **surface** or an **interface** of **many materials**.

○ Application examples (air-liquid interface)



Structure 21, 1822–1833, October 8, 2013



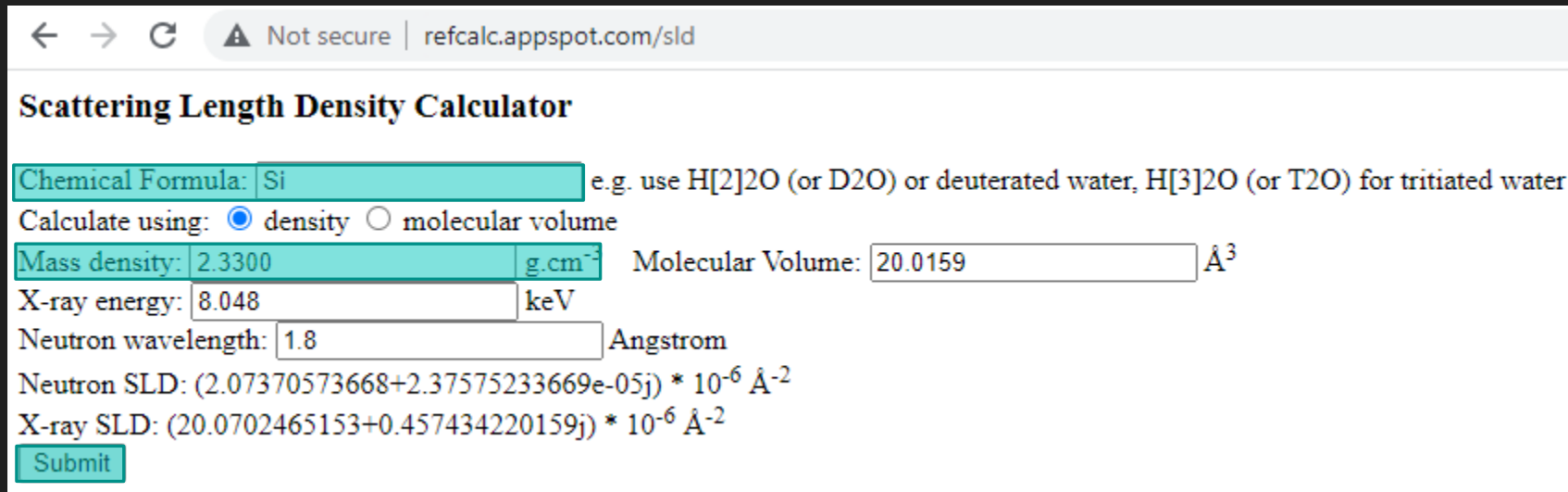
Macromol. Rapid Commun. 21, 243–270 (2000)

What information NR provides?

○ Scattering length density (SLD) vs. depth profile

(composition vs. depth profile; concentration vs. depth profile; etc.)

SLD calculator: <http://www.refcalc.appspot.com/sld>



The screenshot shows a web browser window with the URL `refcalc.appspot.com/sld`. The page title is "Scattering Length Density Calculator". The form contains the following fields and values:

- Chemical Formula: e.g. use H[2]O (or D2O) or deuterated water, H[3]O (or T2O) for tritiated water
- Calculate using: density molecular volume
- Mass density: g.cm^{-3} Molecular Volume: \AA^3
- X-ray energy: keV
- Neutron wavelength: Angstrom
- Neutron SLD: $(2.07370573668+2.37575233669e-05j) * 10^{-6} \text{\AA}^{-2}$
- X-ray SLD: $(20.0702465153+0.457434220159j) * 10^{-6} \text{\AA}^{-2}$
- Submit button

What is a SLD vs. depth profile?

○ Example

→ **H₂O** Density: 0.997 g/cm³
SLD (neutron) = $-0.56 \times 10^{-6} \text{ \AA}^{-2}$
SLD (X-ray) = $9.44 \times 10^{-6} \text{ \AA}^{-2}$

→ **D₂O** Density: 1.10 g/cm³
SLD (neutron) = $6.37 \times 10^{-6} \text{ \AA}^{-2}$
SLD (X-ray) = $9.43 \times 10^{-6} \text{ \AA}^{-2}$

→ **H₂O:D₂O = 91.9: 8.1** Density: 1.0 g/cm³
SLD (neutron) = $0.00 \times 10^{-6} \text{ \AA}^{-2}$
SLD (X-ray) = $9.43 \times 10^{-6} \text{ \AA}^{-2}$

→ **BSA protein**
Density: 2.32 g/cm³

○ practice

→ PMMA

Formula: (C₅O₂H₈)_n

Density: 1.18 g/cm³

SLD = $1.06 \times 10^{-6} \text{ \AA}^{-2}$

→ dPC

Formula: (C₁₆O₄H₁₂D₆)_n

Density: 1.22 g/cm³

SLD = $3.27 \times 10^{-6} \text{ \AA}^{-2}$

→ Si

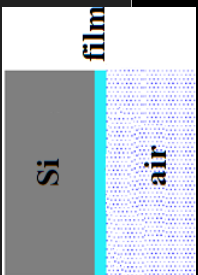
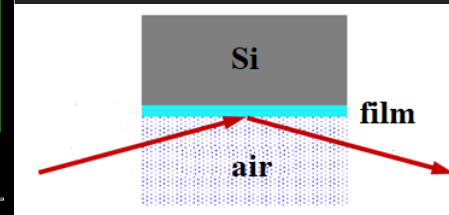
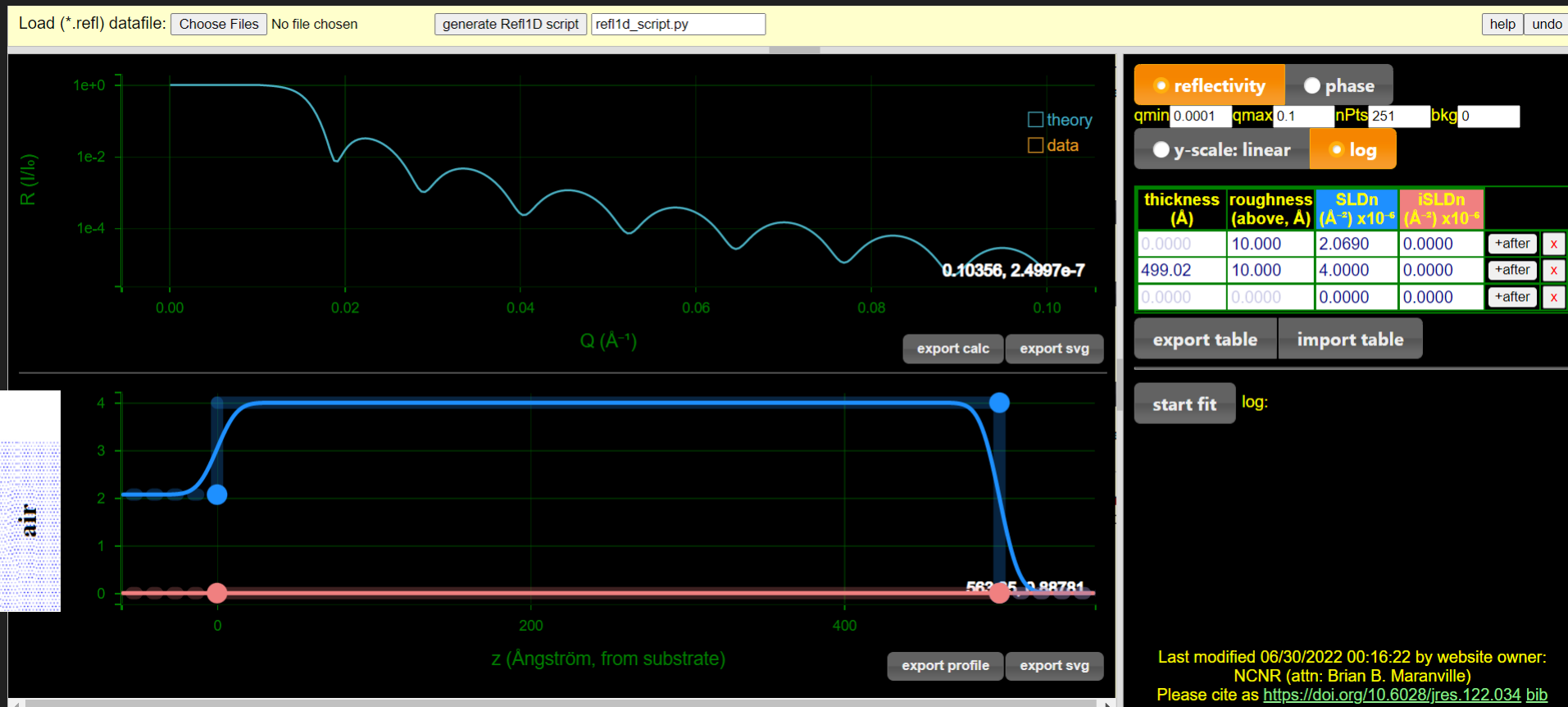
Formula: Si

Density: 2.32 g/cm³

SLD = $2.07 \times 10^{-6} \text{ \AA}^{-2}$

Data fitting (R → SLD profile)

<https://ncnr.nist.gov/instruments/magik/calculators/reflectivity-calculator.html>



Last modified 06/30/2022 00:16:22 by website owner:
NCNR (attn: Brian B. Maranville)
Please cite as <https://doi.org/10.6028/jres.122.034> bib

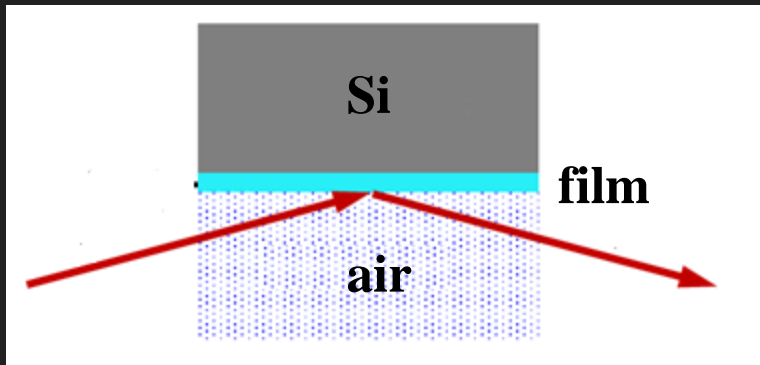
Thickness & Reflectivity

<https://ncnr.nist.gov/instruments/magik/calculators/reflectivity-calculator.html>

○ practice

➔ Single layer film on Si substrate

Vary film thickness
(100, 250, 1000)



reflectivity phase

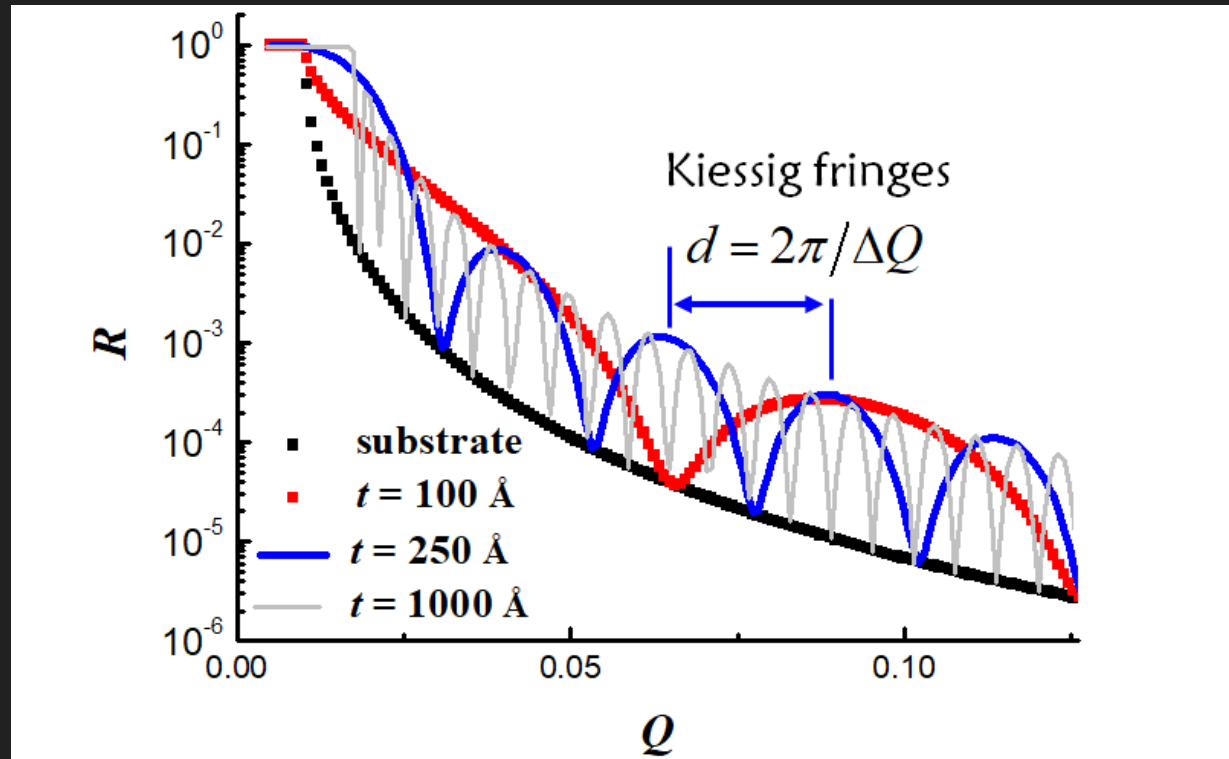
qmin 0.0001 qmax 0.2 nPts 251 bkg 0

y-scale: linear log

thickness (Å)	roughness (above, Å)	SLDn $\times 10^{-6}$	iSLDn $\times 10^{-6}$		
0.0000	10.000	2.0690	0.0000	+after	x
<input type="text" value="400.00"/>	10.000	6.0000	0.0000	+after	x
0.0000	0.0000	0.0000	0.0000	+after	x

export table import table

Thickness & Reflectivity



thickness

period

$$\text{at large } Q, \quad R \approx (16\pi^2/Q^4)[\rho^2 + (\rho_s - \rho)^2 + 2\rho(\rho_s - \rho) \cos(Qd)]$$

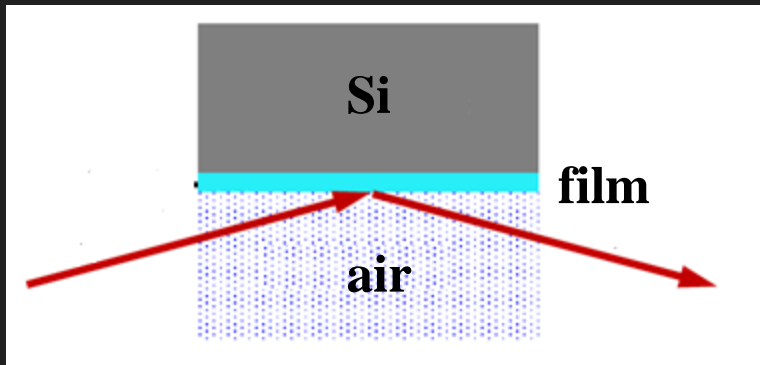
SLD & Reflectivity

<https://ncnr.nist.gov/instruments/magik/calculators/reflectivity-calculator.html>

○ practice

➔ Single layer film on Si substrate

Vary film SLD
(1.0, 2.07, 3.0, 6.0)



reflectivity phase

qmin 0.0001 qmax 0.2 nPts 251 bkg 0

y-scale: linear log

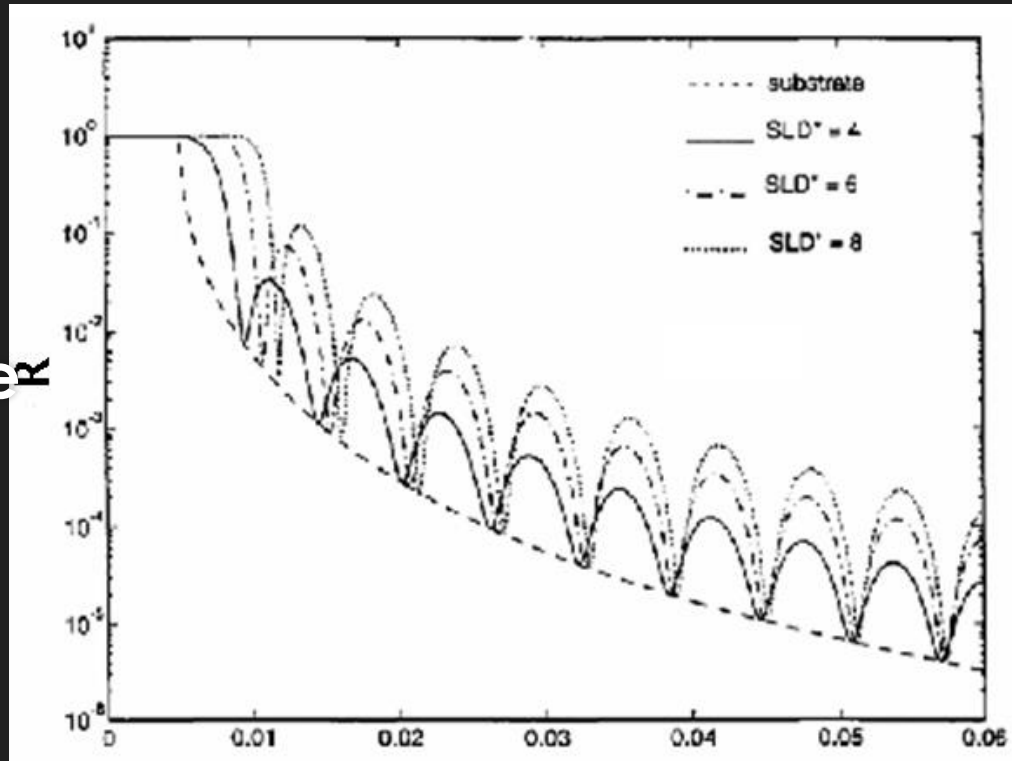
thickness (Å)	roughness (above, Å)	SLDn x10 ⁻⁹	iSLDn x10 ⁻⁹		
0.0000	10.000	2.0690	0.0000	+after	x
500.00	10.000	<input type="text" value="1.0000"/>	0.0000	+after	x
0.0000	0.0000	0.0000	0.0000	+after	x

export table import table

SLD & Reflectivity

composition (SLD)

amplitude R



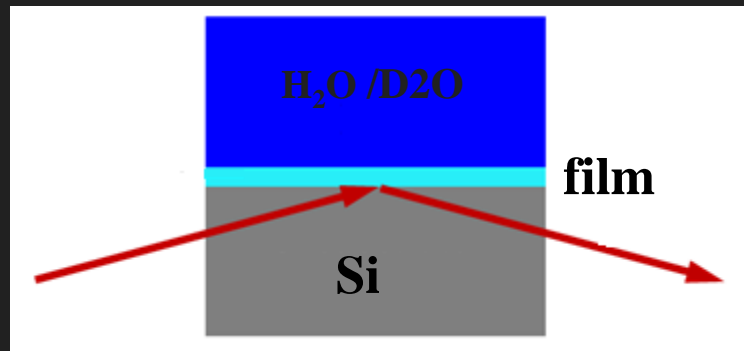
$$\text{at large } Q, \quad R \approx (16\pi^2/Q^4)[\rho^2 + (\rho_s - \rho)^2 + 2\rho(\rho_s - \rho) \cos(Qd)]$$

SLD & Reflectivity

<https://ncnr.nist.gov/instruments/magik/calculators/reflectivity-calculator.html>

○ practice

Vary substrate SLD (-0.56; 1; 6.33)



reflectivity phase

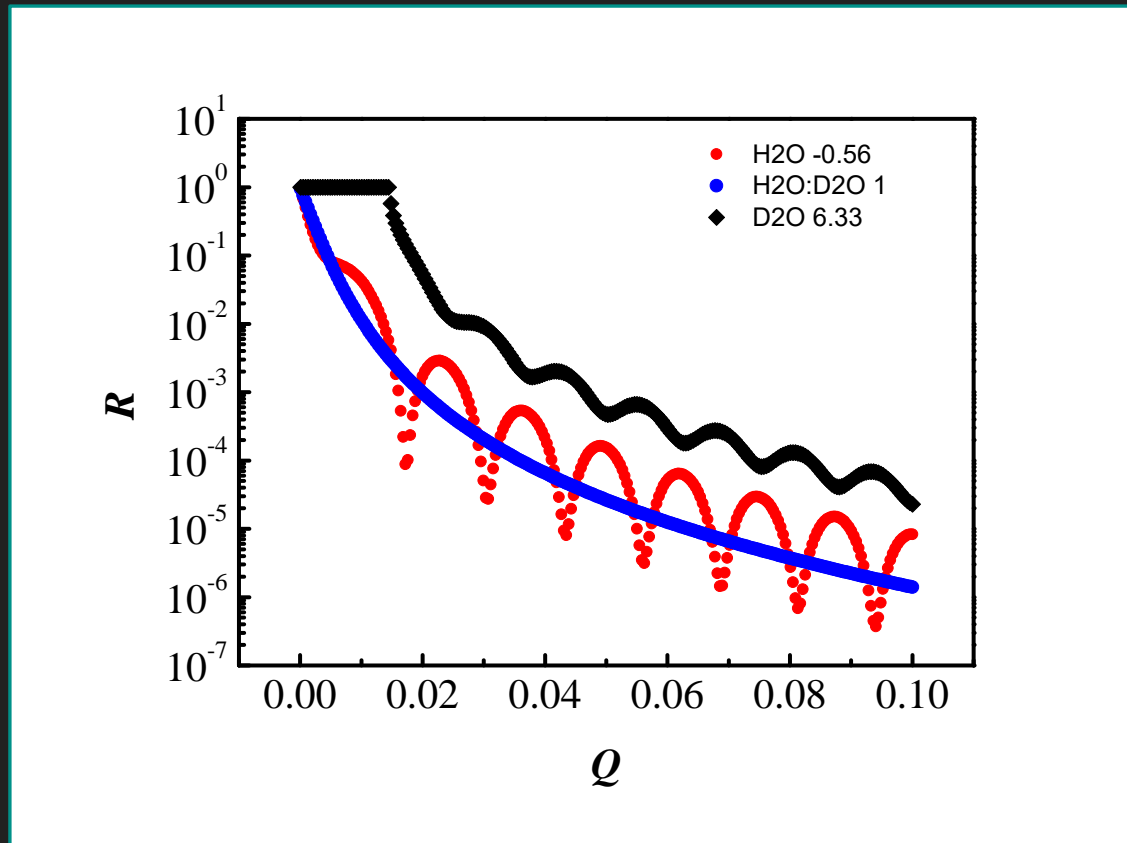
qmin 0.0001 qmax 0.2 nPts 251 bkg 0

y-scale: linear log

thickness (Å)	roughness (above, Å)	SLDn x10 ⁻⁹	iSLDn x10 ⁻⁹		
0.0000	10.000	-0.56000	0.0000	+after	x
500.00	10.000	1.0000	0.0000	+after	x
0.0000	0.0000	2.0700	0.0000	+after	x

export table import table

SLD & Reflectivity



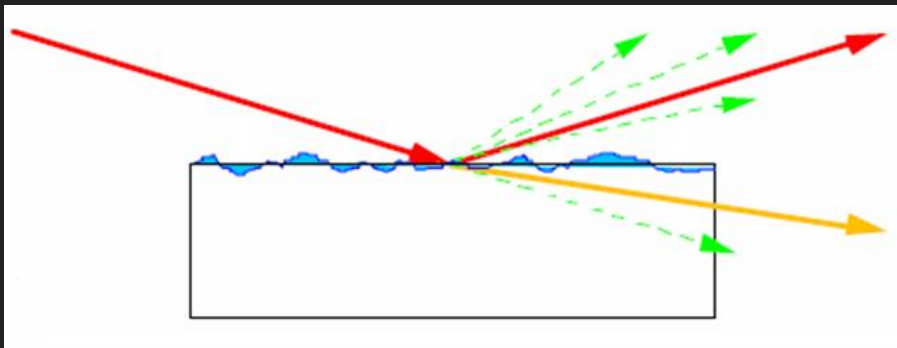
Roughness & Reflectivity

<https://ncnr.nist.gov/instruments/magik/calculators/reflectivity-calculator.html>

○ practice

→ Single layer film on Si substrate

Vary film roughness
(0, 10, 50, 100)



○ reflectivity ○ phase

qmin 0.0001 qmax 0.2 nPts 251 bkg 0

○ y-scale: linear ○ log

thickness (Å)	roughness (above, Å)	SLDn $\times 10^{-9}$	iSLDn $\times 10^{-9}$		
0.0000	10.000	2.0690	0.0000	+after	x
500.00	<input type="text" value="10.000"/>	6.0000	0.0000	+after	x
0.0000	0.0000	0.0000	0.0000	+after	x

export table import table

Roughness & Reflectivity

at large Q , for flat surface and interface,

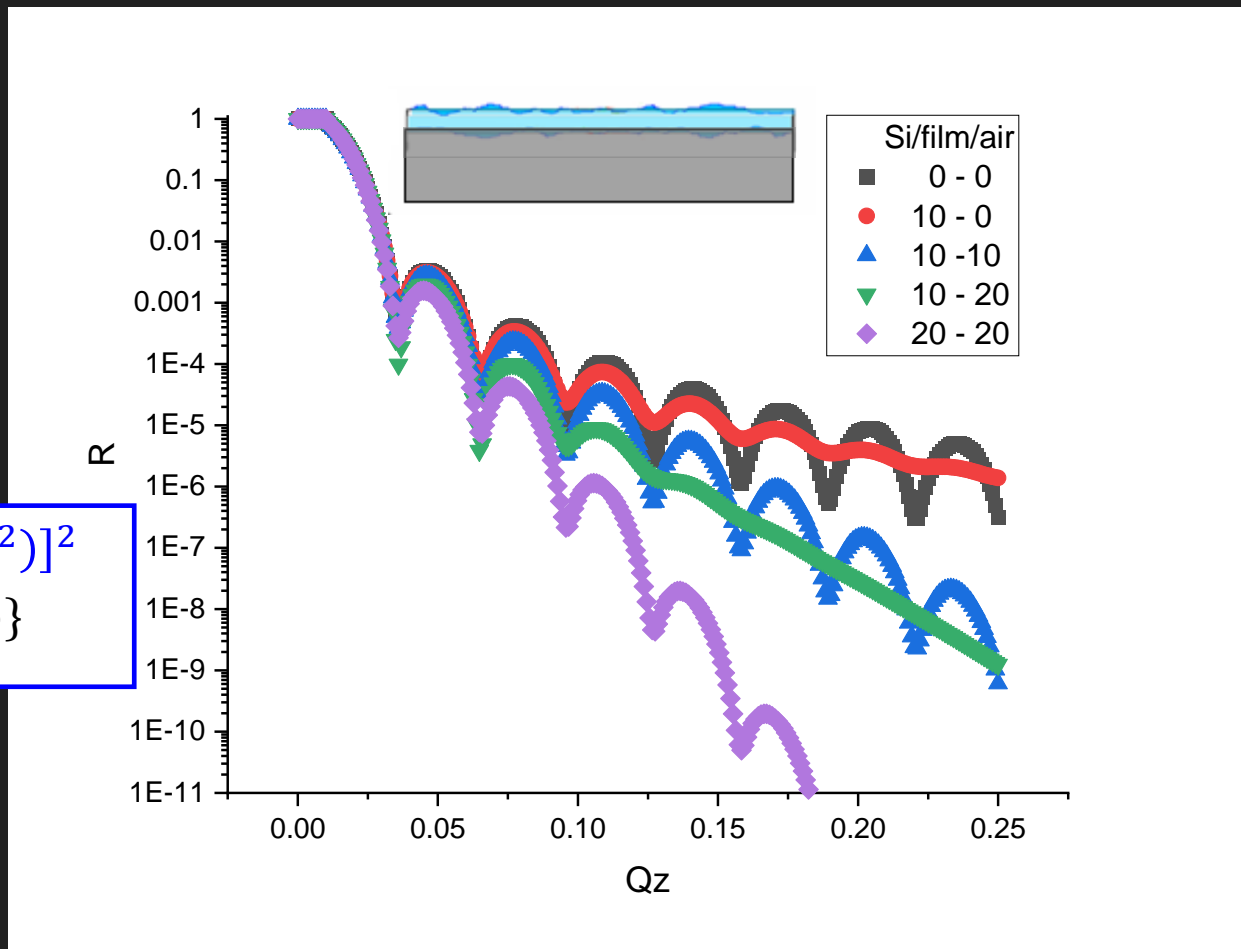
$$R \approx (16\pi^2/Q^4)[\rho^2 + (\rho_s - \rho)^2 + 2\rho(\rho_s - \rho) \cos(Qd)]$$

at large Q , for diffuse surface and interface,

$$R \approx (16\pi^2/Q^4)\{\rho^2[\exp(-\sigma_1^2 Q^2)]^2 + (\rho_s - \rho)^2[\exp(-\sigma_2^2 Q^2)]^2 + 2\rho(\rho_s - \rho) \exp(-\sigma_1^2 Q^2) \exp(-\sigma_2^2 Q^2) \cos(Qd)\}$$

roughness (interfacial width)

decay



NR summary

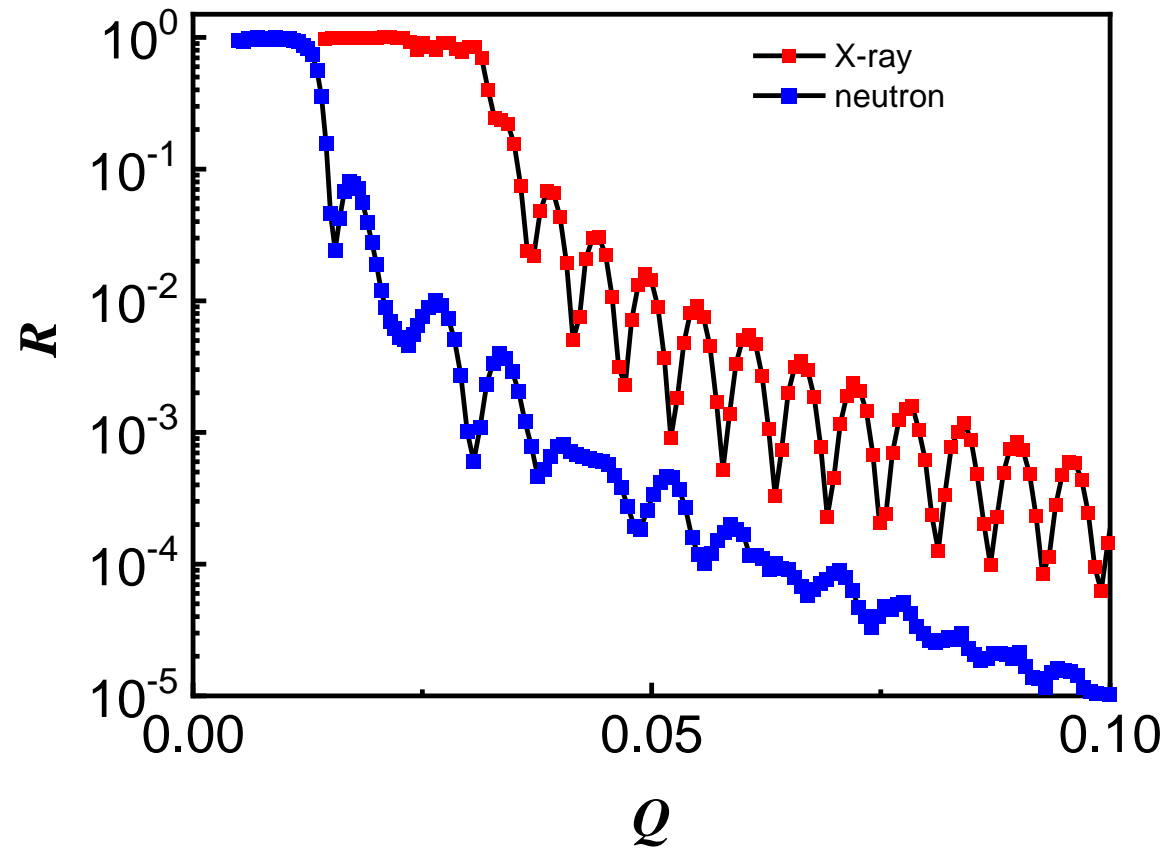
$$R = \frac{I_{\text{reflection}}}{I_{\text{incident}}} = f(Q, \rho, n, d, \sigma \dots)$$

Substrate: Si, quartz, sapphire

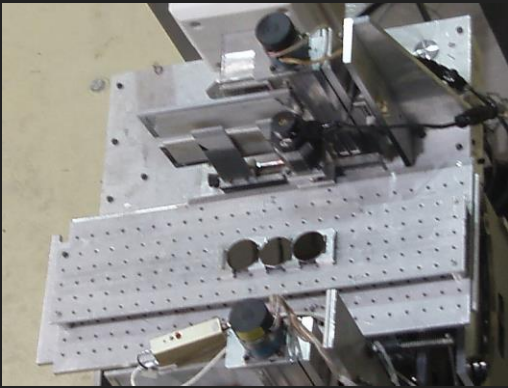
Sample Size: 2 ~ 4 inches

Typical Cases: diffusion, corrosion, adsorption, segregation, deposition...

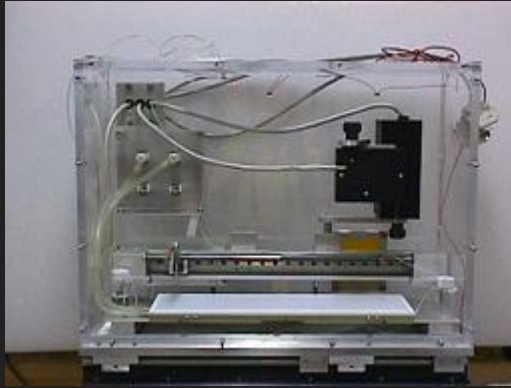
X-ray & Neutron Comparison



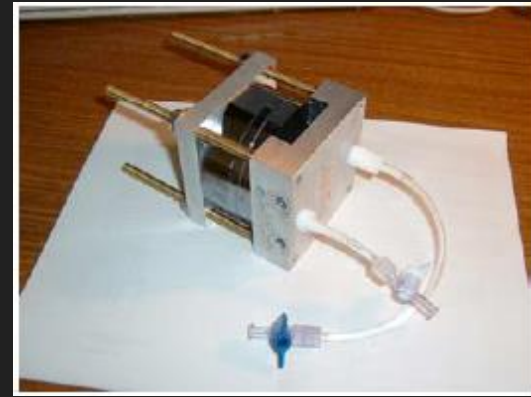
Sample environments



solid/air



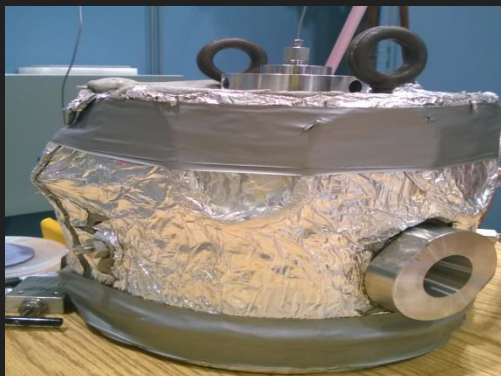
liquid/air



solid/liquid

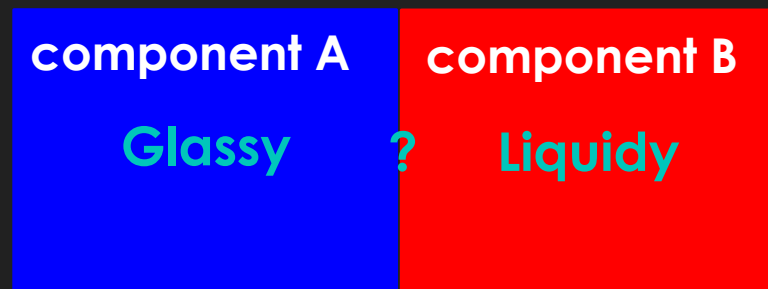


vacuum, humidity, pressure ...



Experiment

Neutron Reflectivity Investigation of the **Propagation** (transportation, diffusion, sorption, etc.) of a **Melt Polymer** across a **Glassy polymer Interface**

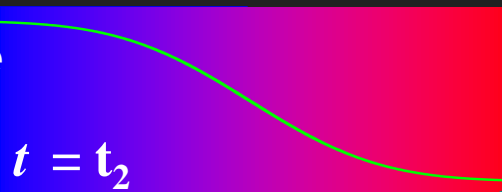
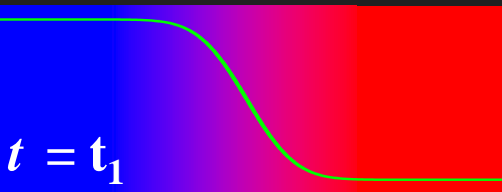
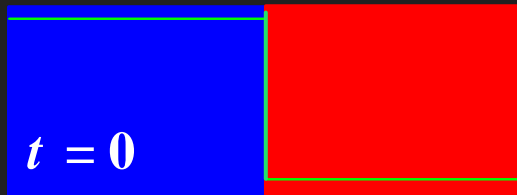


Background: types of diffusion

Fick's law of diffusion: $J = -D\nabla\varphi$ (Adolf Fick in 1855)

Fickian diffusion

(i.e. Case I diffusion)



No clear boundaries

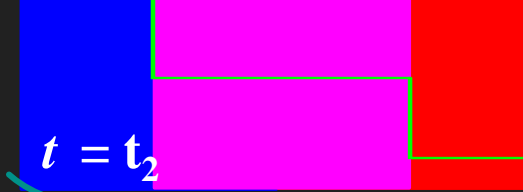
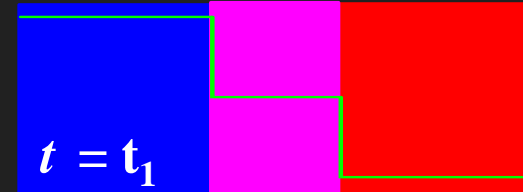
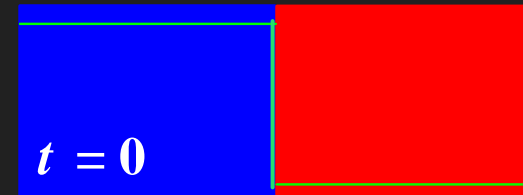
mass uptake
 $M \propto t^{1/2}$

Non-Fickian diffusion

Anomalous diffusion

A combination of Case I and Case II diffusion to different extents

Case II diffusion



Sharp front

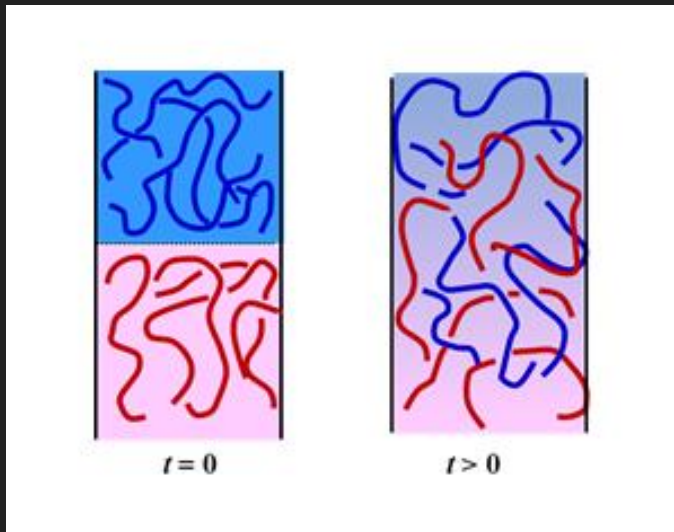
mass uptake
 $M \propto t$

What causes different types of diffusion?

Case I diffusion

(e.g. PS/dPS, PMMA/dPMMA)

$$T > T_{gA}, T_{gB}$$



diffusion control
(relaxation negligible)

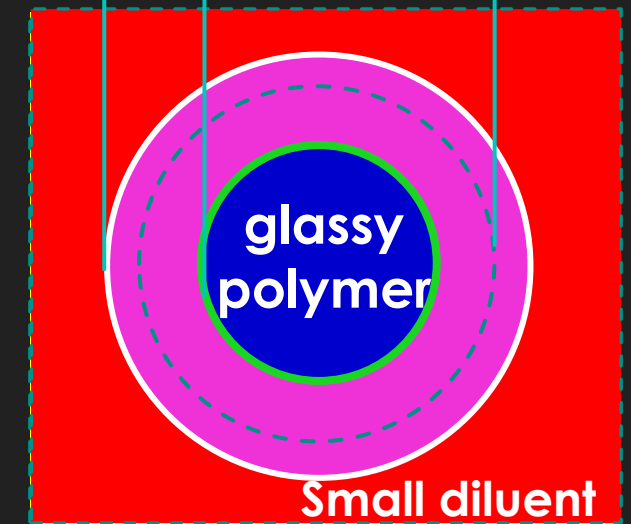
Anomalous diffusion
Comparable diffusion
and relaxation effects

Case II diffusion

(e.g. PMMA rod/methanol)

$$T < T_{gA}, T \gg T_{gB}$$

penetrating front
swelling front
initial surface



relaxation control

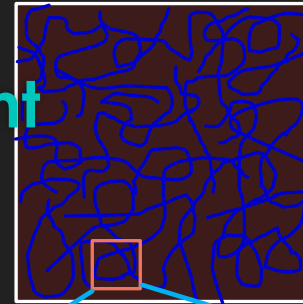
Polymer basics

○ chain-like structure
 M_n, M_w

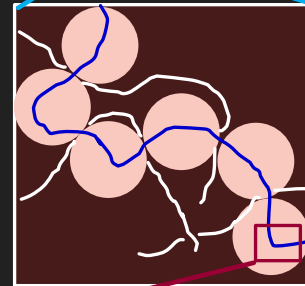
→ Repeat units



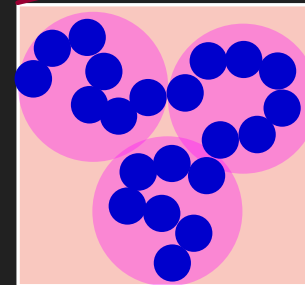
○ Entanglement
 M_e



'Rouse blob'



'thermal blob'



(q, τ)

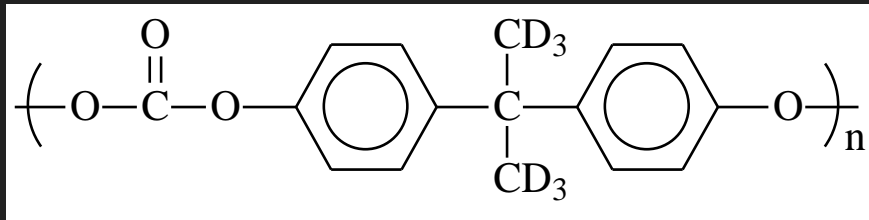
○ Glass transition
 T_g

System investigated

component A

○ deuterated polycarbonate

dPC



$T_g \approx 151 \text{ }^\circ\text{C}$

$M_n = 8.4 \times 10^4 \text{ g/mol}$

$R_g = 11.0 \text{ nm}$

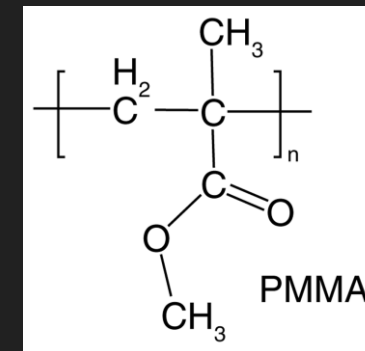
$M_e = 11,60 \text{ g/mol}$

highly entangled

component B

○ poly(methyl methacrylate)

PMMA



$T_g \approx 88 \text{ }^\circ\text{C}$

$M_n = 4.0 \times 10^3 \text{ g/mol}$

$R_g = 1.6 \text{ nm}$

non-entangled

(M_e : average molecular weight between entanglement points)

Objective

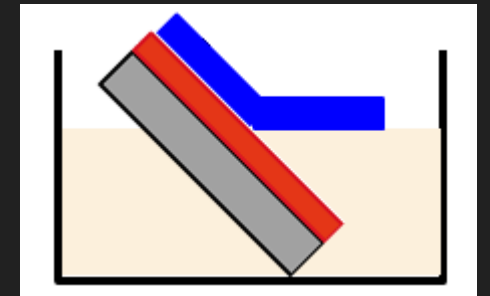
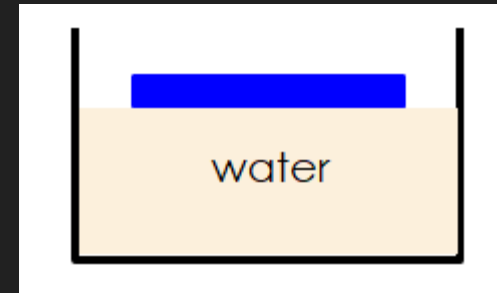
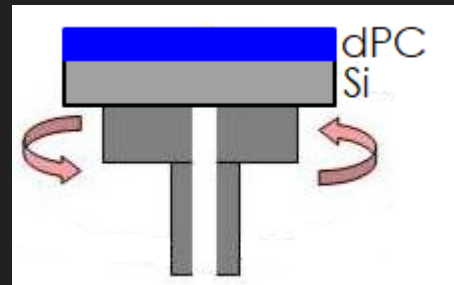
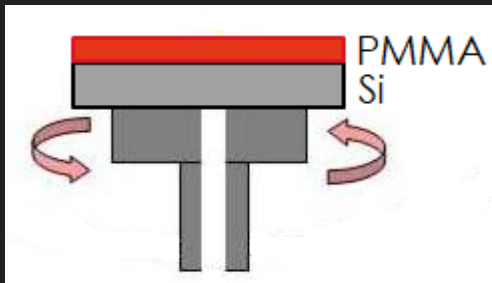


- To learn reflectivity measurements on bilayer polymer thin films.
- To determine the time evolution of interfacial profile.
- To play with the chain-like feature of polymers and understand its effect on interdiffusion.

Sample preparation

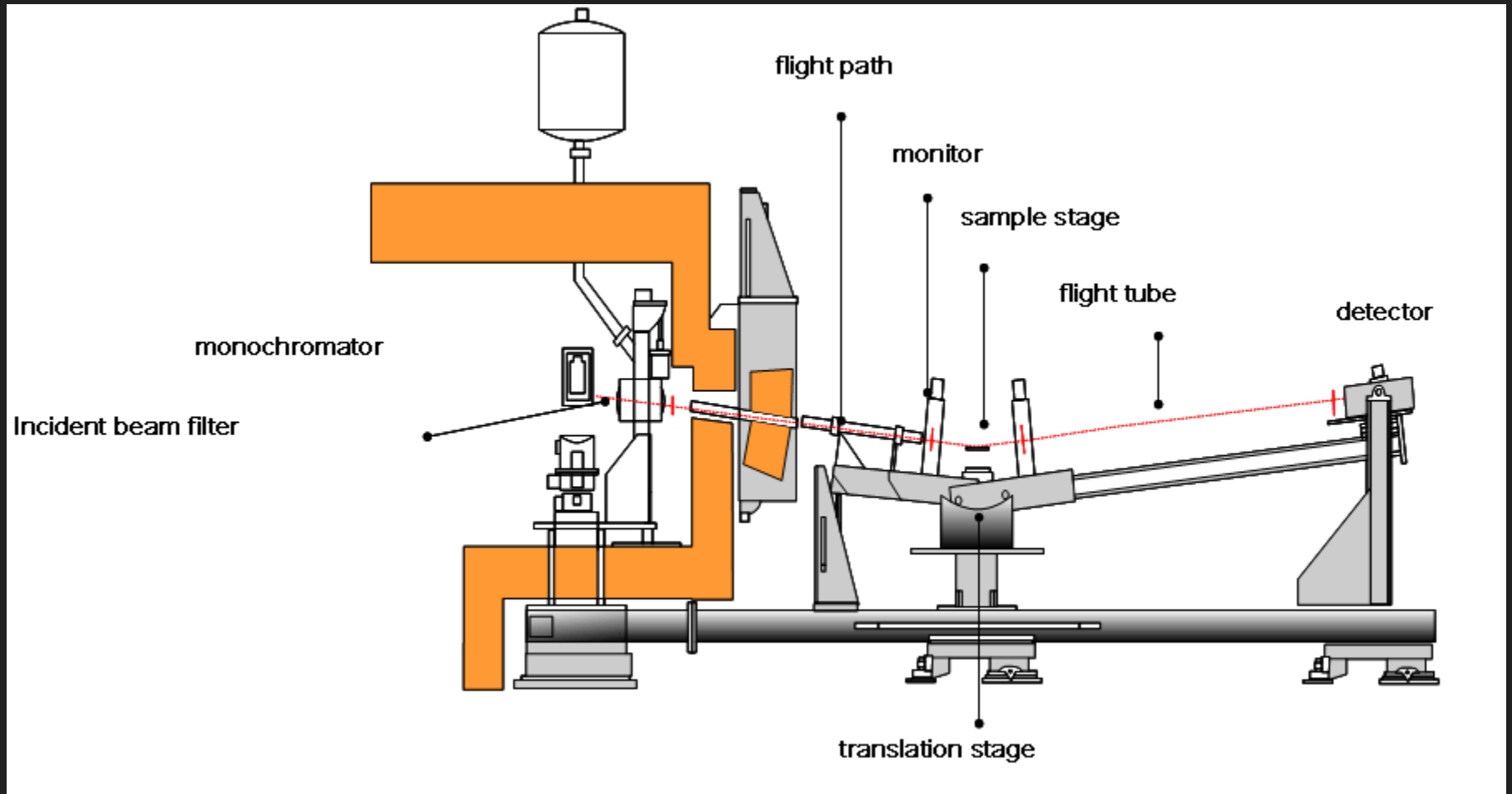
○ dPC/PMMA/Si

- ➔ Step 1 Remove the silicon oxide layer from the Si substrate (First “piranha” solution (70/30 v/v H_2SO_4 (50%)/ H_2O_2 (30%)) and then 5 % HF solution)
- ➔ Step 2 Spin coat a PMMA layer on the cleaned Si wafer
- ➔ Step 3 Spin coat a dPC layer on another Si wafer
- ➔ Step 4 Float the dPC film on the water surface then pick it up on the wafer with PMMA layer



NR measurement

○ instrument



Data reduction

- ➔ <https://reductus.nist.gov/>
- ➔ Template _ unpolarized
- ➔ ncnrdata/ng7/201608/22440/data/1-4E3

Specular

7204 (as-cast)

7419 (20 min at 135 °C)

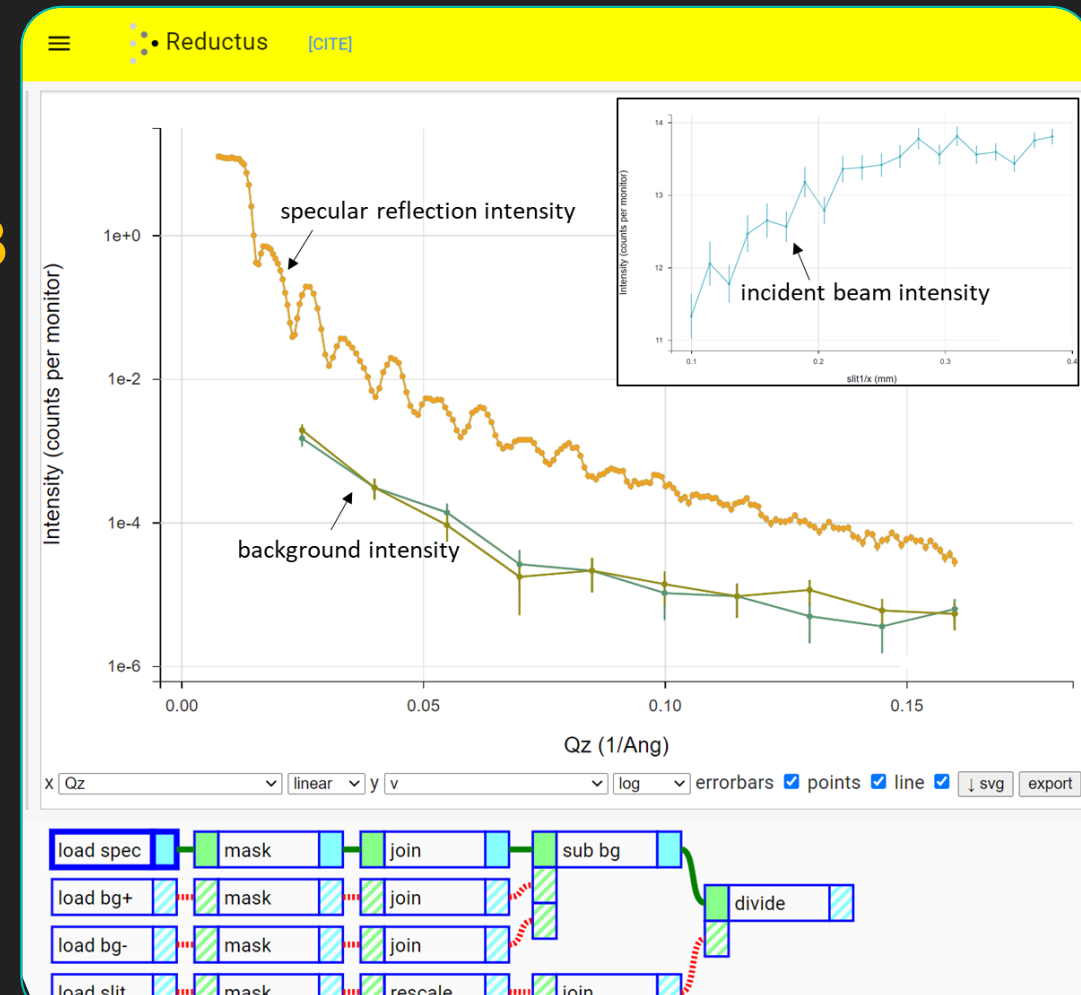
7619 (65 min at 135 °C)

Background

7205, 7206 (+, -)

Slits

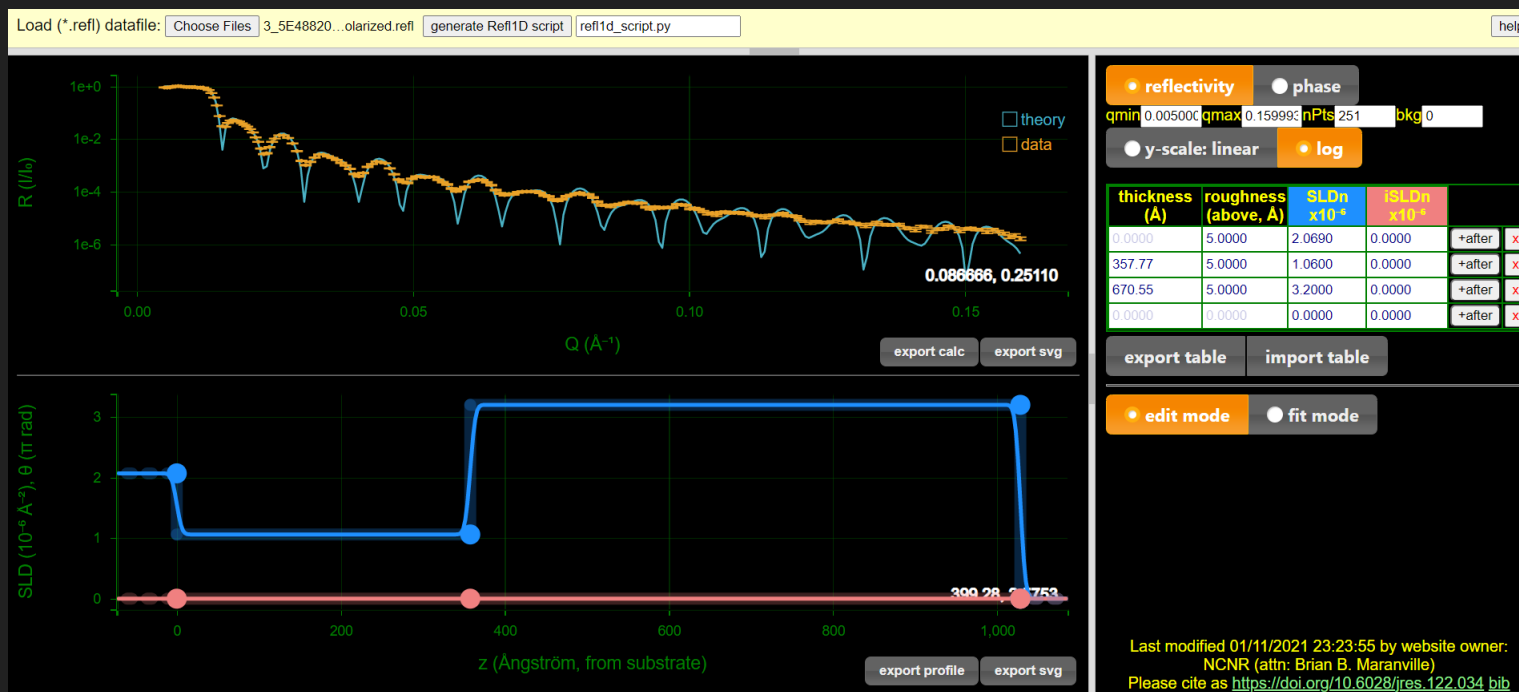
7127 (35 mm beam through air)



Data fitting

○ Generate refl1D script

<https://ncnr.nist.gov/instruments/magik/calculators/reflectivity-calculator.html>

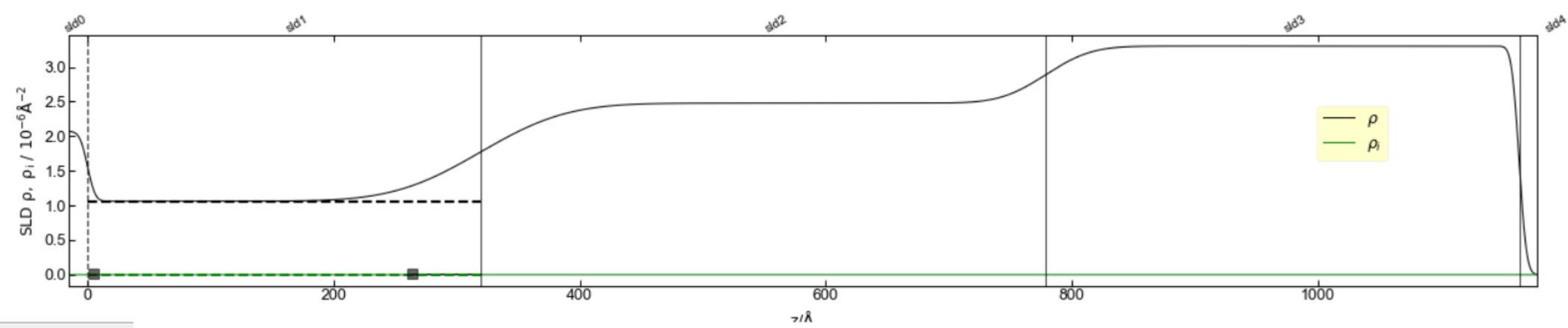
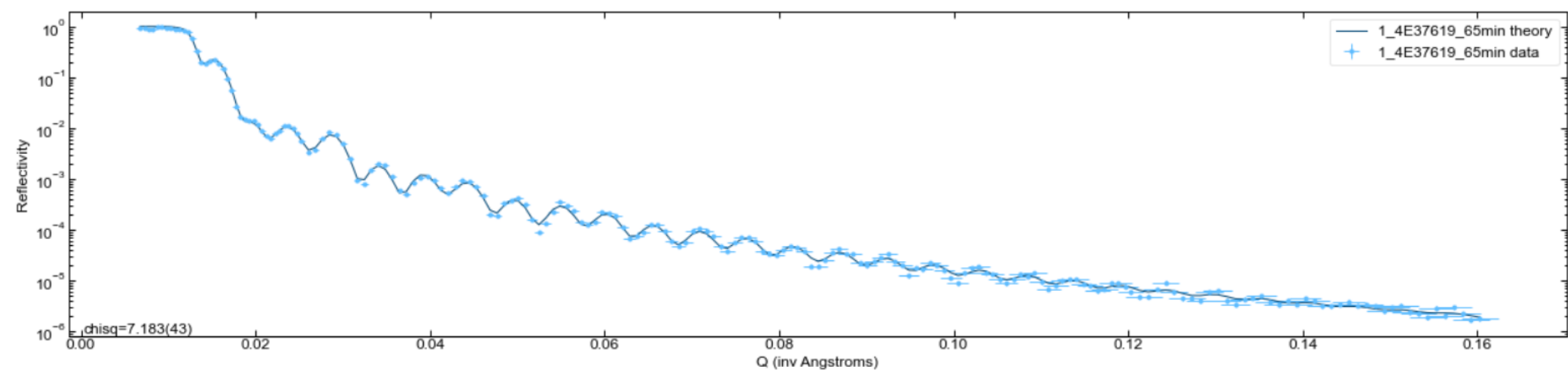


Data fitting

○ Edit refl1D script

- ➔ Load data
- ➔ Stack layers
- ➔ Set constraints
- ➔ Fit parameters

```
refl1d_script (2).py x
1  from refl1d.names import *
2  from copy import copy
3  ## === Data files ===
4  probe = load4('1_4E37619_65min.refl', back_reflectivity=False)
5  #probe = Probe(T=numpy.linspace(0.14829, 3.6500, 251), L=5.0000)
6
7  # Background parameter
8  probe.background.value = 0.0000
9  # probe.background.range(1e-9, 1e-5)
10
11  ## === Stack ===
12  ##
13  ## First, we create a 'material' for each layer, which has an real and imaginary
14  ## scattering length density, stored in a Refl1d object called 'SLD'
15  sld0 = SLD(name='Si', rho=2.0690, irho=0.0000)
16  sld1 = SLD(name='PMMA', rho=1.0600, irho=0.0000)
17  sld2 = SLD(name='Mix', rho=2.4500, irho=0.0000)
18  sld3 = SLD(name='dPC', rho=3.2800, irho=0.0000)
19  sld4 = SLD(name='Air', rho=0.0000, irho=0.0000)
20
21  ## Then layers are created, each with its own 'material'. If you want to force
22  ## two layers to always match SLD you can use the same material in multiple layers.
23  ## The roughnesses of each layer are set to zero to begin with:
24  layer0 = Slab(material=sld0, thickness=0.0000, interface=5.0000)
25  layer1 = Slab(material=sld1, thickness=319.15, interface=55.000)
26  layer2 = Slab(material=sld2, thickness=459.75, interface=30.000)
27  layer3 = Slab(material=sld3, thickness=384.36, interface=5.000)
28  layer4 = Slab(material=sld4, thickness=0.0000, interface=0.0000)
29
30  sample = Stack()
31  sample.add(layer0)
32  sample.add(layer1)
33  sample.add(layer2)
34  sample.add(layer3)
35  sample.add(layer4)
```



Conclusion